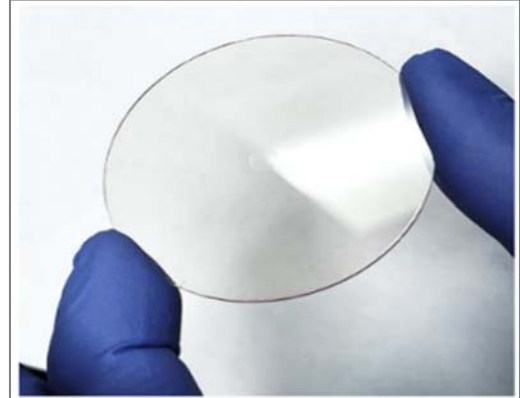





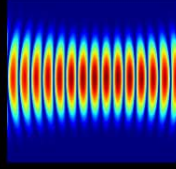
## STOB Series Flat Lenses

Our flat lenses are perfect for laser processing tools. They provide extended depth-of-field, making it easy to mark a variety of objects with precision. Whether you need to mark a metal part with a serial number or weld a plastic part together, this lens will make the job easy. It is a new generation of ultralight, low cost, high performance metalens surfaces.

Our lenses are perfect for applications where high resolution over an extended depth of field is required. Each lens has a very low profile, making it easy to integrate into your system. It is also customizable for any laser wavelength and beam diameter, making it perfect for your needs. Our lenses are carefully crafted via lithography to provide the best results each time. With our lenses, you can experience enhanced precision, quality, and reliability in a variety of laser processing tools.



We have created an advanced optical surface design technology that enables ultralight, low cost and high performance metalens surfaces. Our domain expertise in optical design and high precision volume manufacturing allows us to deliver optical performance and capability previously unachievable with traditional refractive, diffractive or metalens methods.

			
<b>TIME OF FLIGHT</b>	<b>LASER MARKING</b>	<b>THERMAL IMAGING</b>	<b>BEAM SHAPING</b>
High resolution LIDAR and time-of-flight optical solutions	Precise laser marking and high power laser machining capabilities	Broadband NIR to LWIR infrared optical imaging solutions	Customized optical elements for beam shaping, diffractive optical (DOE), and diffuser applications

### 1. STOB Series Flat Lenses for Extended Depth of Field

Flat lenses are perfect for laser processing tools, they provide extended depth-of-field, making it easy to mark a variety of objects with precision. Whether you need to mark a metal part with a serial number or weld a plastic part together, this lens will make the job easy. This lens boasts the following advantages:

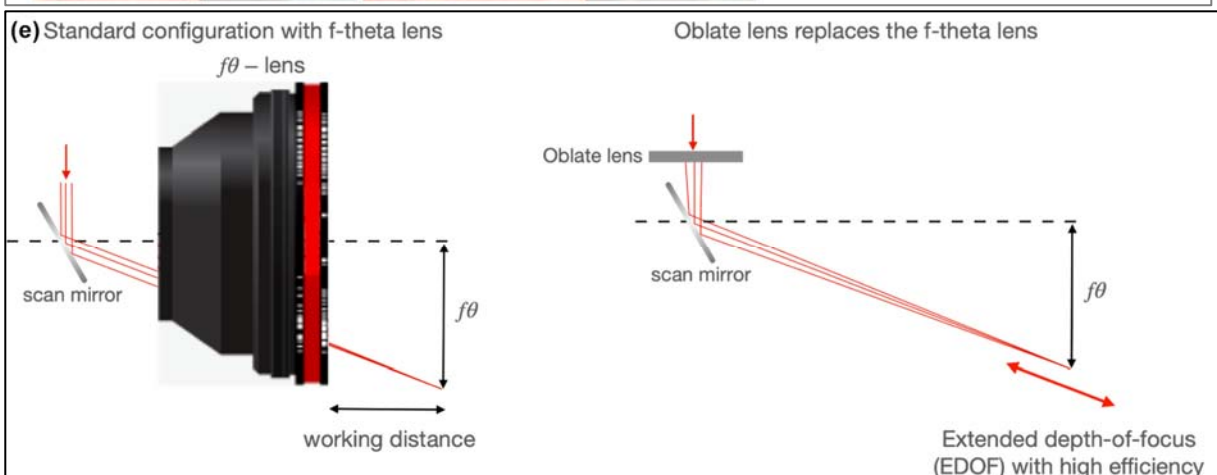
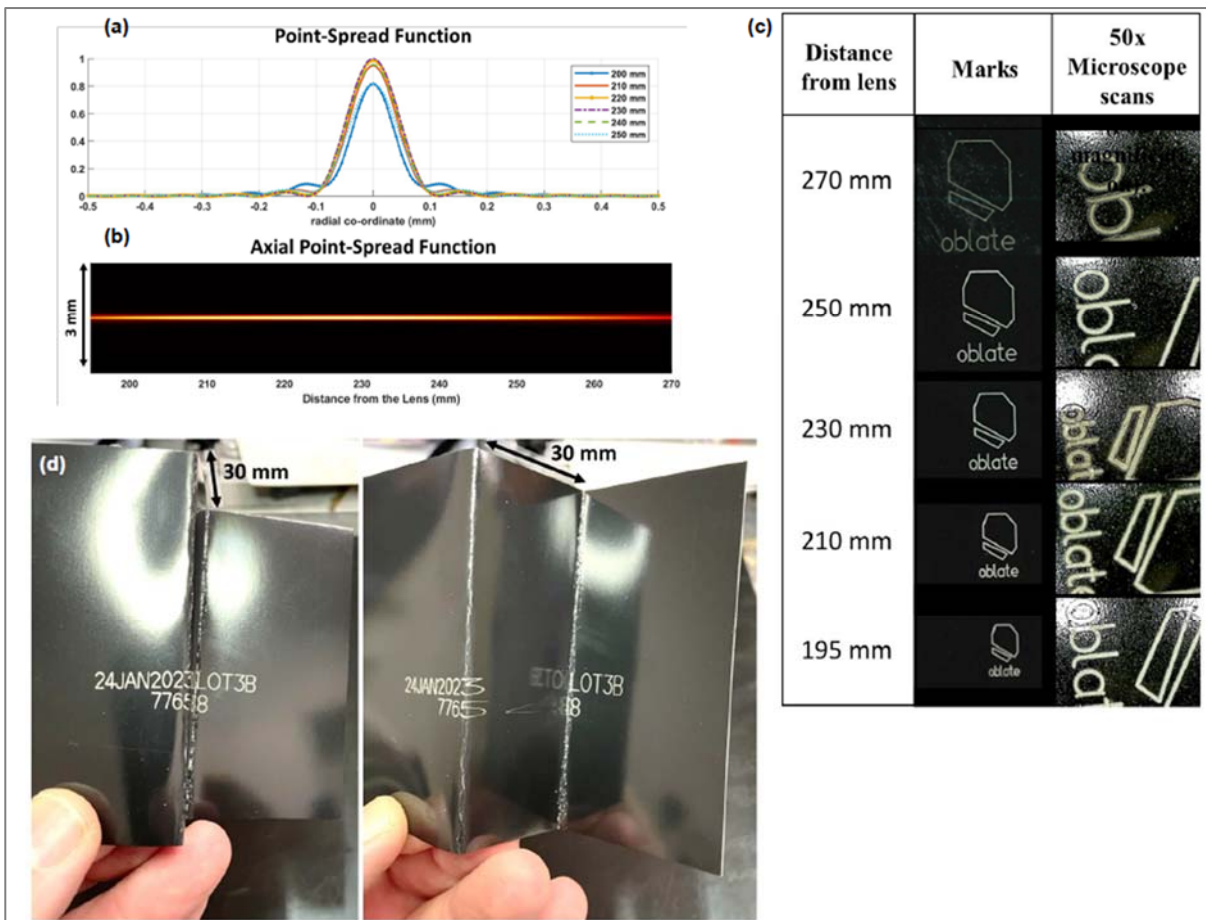
- Extended depth of field (>75 mm)
- Excellent PSF performance
- Ultralow profile
- Low-cost, large volume manufacturing
- Customizable for any laser wavelength
- Tolerant to high laser fluences

#### Specifications:

Optical Specifications	
Wavelength	1064nm
EFL	195-270mm
DOF (extended)	75mm
Lens Diameter	3mm
Transmission Efficiency	>90%
Tolerant to High Laser Power	
Mechanical Specifications	
Diameter	3mm

Thickness	<1mm
Weight	<1gram
<b>PSF Spot Size (FWHM)</b>	
195mm from lens	78 $\mu$ m
225mm from lens	103 $\mu$ m
270mm from lens	98 $\mu$ m

The performance of the extended depth of field (EDOF) flat lens is shown below. The calculated Point-Spread Function (PSF) shows good focusing for the extended depth of focus range in Fig. (a). The calculated PSF as a function of distance from the lens is also shown in Fig. (b). To the right Fig. (c), standard black-card mark tests are shown from 195 - 270 mm from the lens as well as microscope scans of the marks (50x magnification). No refocusing was performed as the target distance was changed. While the size of the mark varies due to galvo drawing, the spot size remains uniform. In the lowermost photographs Fig. (d), a standard black-card mark test was made on a folded card where the two surfaces of the card were spaced 30 mm apart. The markings are clear and distinct on both surfaces. Besides, the flat lens can replace the f-theta lens which is more space-saving and cost-effective, as shown in Fig. (e).



**Ordering number:**

STOB-EDF-WW-XX-YY

WW : wavelength

XX : effective focal length (EFL)

YY : Depth of field

Example: STOB-EDF-1064-195-55

Wavelength = 1064nm

EFL =>195mm

Depth of field = 55mm

The table showing some of our capability is below

Wavelength	EFL	DOF	Diameter	Spot Size
355 nm	25 - 100 mm	25, 50 mm	3 - 6 mm	25 - 250 um
532 nm	25 - 100 mm	25, 50 mm	3 - 6 mm	25 - 250 um
1064 nm	25 - 100 mm	25, 50 mm	3 - 6 mm	25 - 250 um
10.6 um	25 - 100 mm	25, 50 mm	3 - 6 mm	50 - 250 um

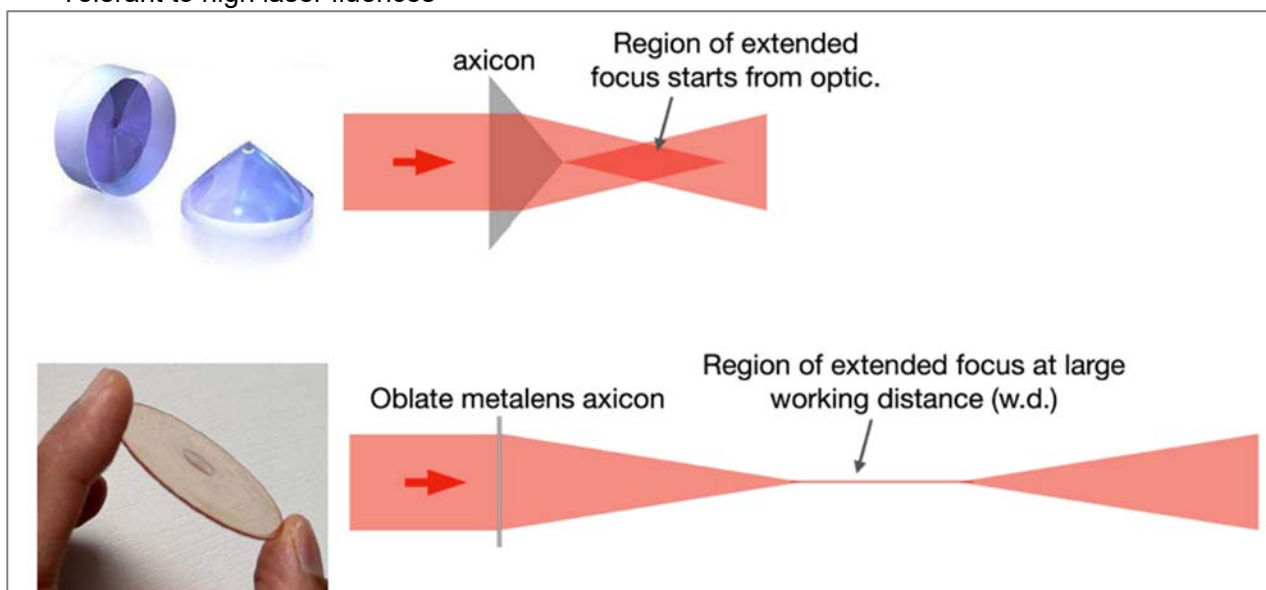
For ordering a metalens, please tell us your requirements on laser wavelength, effective focal length, depth of focus, beam diameter, required focal beam diameter and quantity.

**2. STOB Series Metalens Axicon Lenses for Extended Depth-of-field Application**

We are the exclusive manufacturer of metalens axicon lenses suitable for applications where high resolution over an extended depth-of-field is desired. Applications include laser marking, machining, welding, microscopy, imaging & ophthalmology.

Such lenses afford the following advantages:

- Extended depth-of-focus (for example >70mm @ w.d. of 125mm).
- No need for slow & expensive refocusing mechanisms.
- Larger working distances than conventional axicons (>250mm possible)
- Uniform peak intensity over the extended depth-of-focus (DOF)
- High efficiency & diffraction-limited spot sizes.
- Low cost, thin (<1mm) & lightweight (1g)
- Customizable for any laser wavelength & beam diameter
- Tolerant to high laser fluences



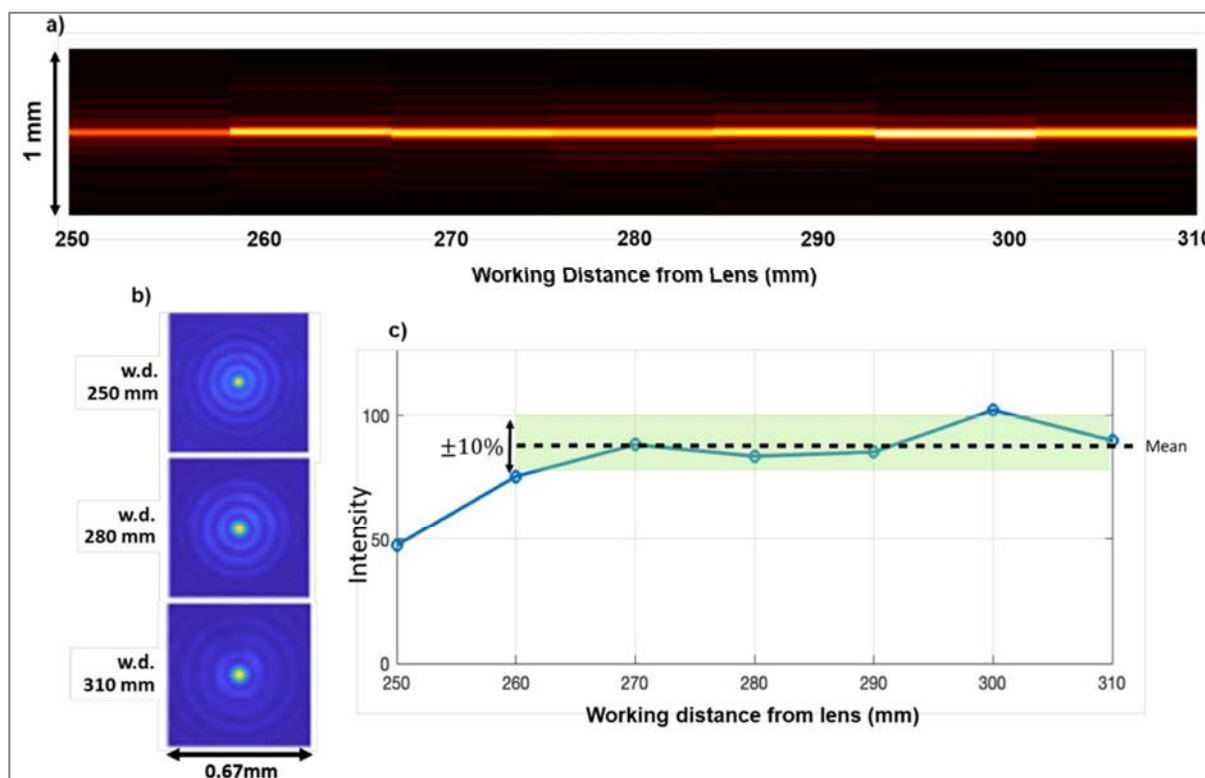
The following lens specification are representative of our axicon metalens technology capability. Please contact us for other specifications.

Part Number	STOB-1064-6-280
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Wavelength	1064nm
Diameter	6mm
EFL	280mm
DOF (extended)	50mm
Spot Size (FWHM)	<67 $\mu$ m
On-Axis Intensity Variation	+/- 10%

### Experimental Data

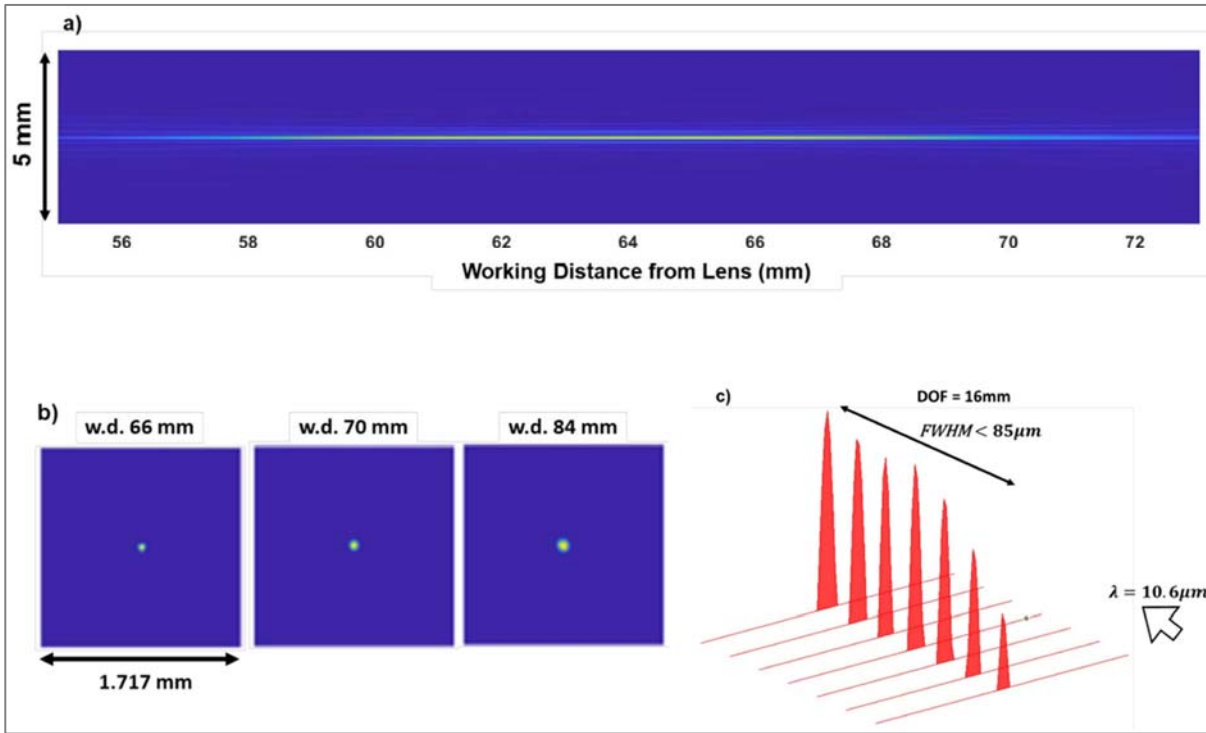
- axial Point-Spread Function
- Point-Spread Function at three distances from the lens,
- Peak intensity of on-axis spot. Variation along the working distance is +/-10%



Part Number	STOB-10.6-8-64
Wavelength	10.6 $\mu$ m
Diameter	8mm
EFL	64mm
DOF (extended)	16mm
Spot Size (FWHM)	<85 $\mu$ m

### Experimental Data and Compute Simulations

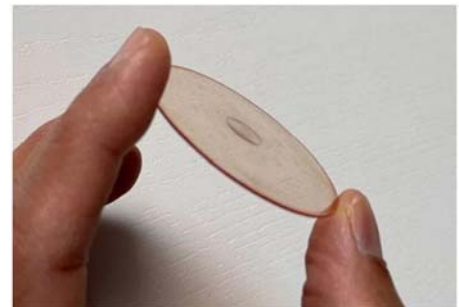
- Computer simulation of axial point-spread function
- Experimental data of point-spread function at three distances from the lens
- Experimental data showing measured depth of field and FWHM of spot size.



### 3. STOB Series FOV Infrared Lenses for Time-of-Flight Applications

We have designed and built an ultra-low profile diffractive metalens suitable for applications where an extended field of view is required. This technology boasts the following advantages:

- Field of view of 80 degrees
- Excellent PSF performance
- Ultralow TTL (< 2.5 mm)
- Low-cost, large volume manufacturing
- Customizable for any wavelength

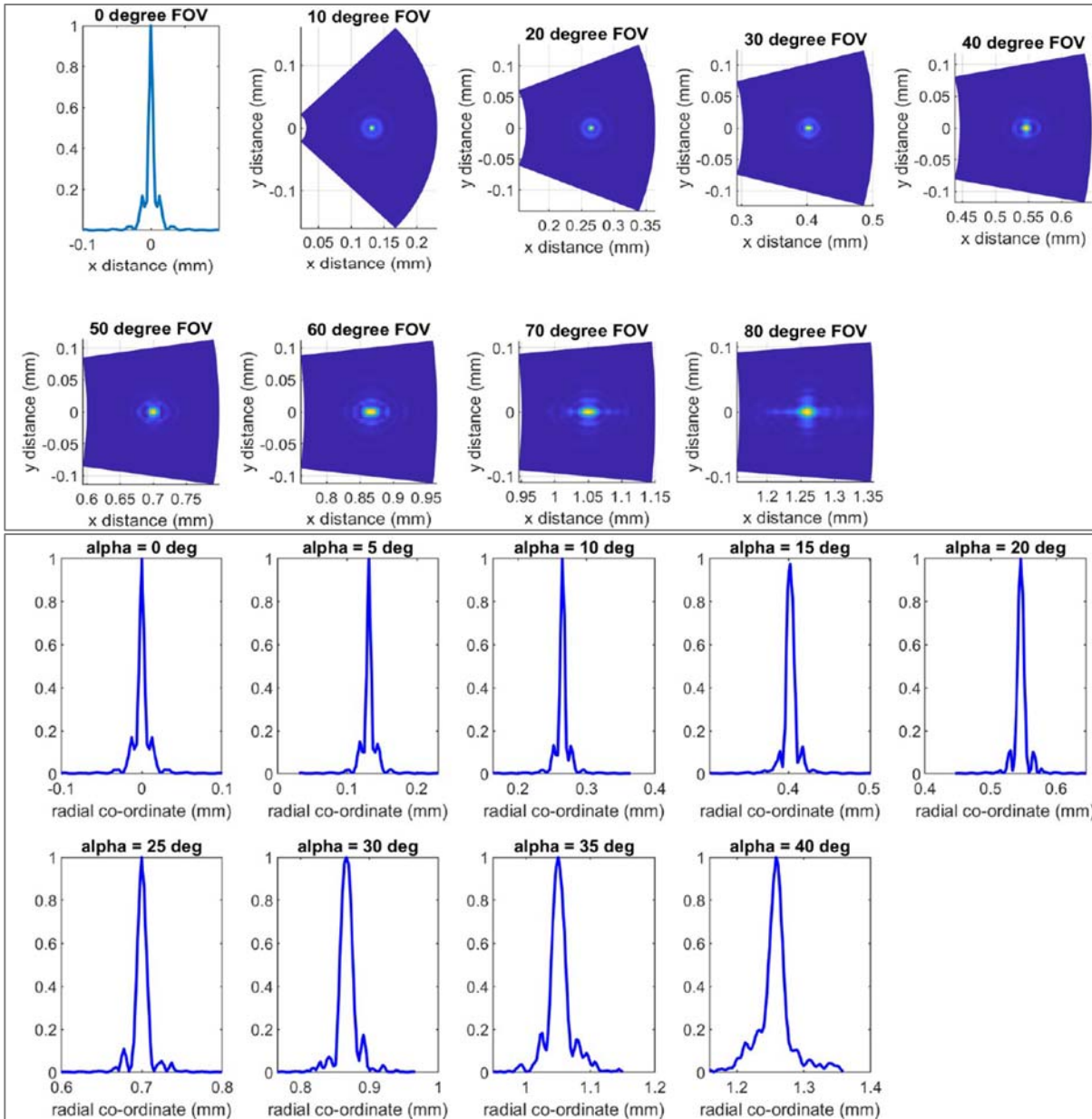


The following lens specifications are representative of our infrared metalens technology capability. Please contact us for custom requirements and design capabilities.

#### Specifications of the STOB Series Infrared TOF metalens with Large Field of View

Optical Specifications	
Wavelength	850nm
EFL	1.5mm
FOV	80 degrees
Spot size (FWHM)	Diffraction limited
Lens Diameter	0.42mm
Transmission Efficiency	>90%
Mechanical Specifications	
Diameter	0.42mm
Thickness	<1mm
Weight	<1gram
Spot Size (FWHM)	
0 degrees	7.3μm
40 degrees	10.7μm
80 degrees	22.4μm

The performance of the large field-of-view TOF metalens is shown below as Point-spread Function (PSF) at 850 nm. The PSF shows high performance focusing for the entire field of view 80 degrees.



**Ordering number:**

STOB-LFV-WW-XX-YY

WW : wavelength

XX : effective focal length (EFL)

YY : field of view (FOV)

Example:

STOB-LFV-1064-2-70

Wavelength = 1064nm

EFL = 2mm

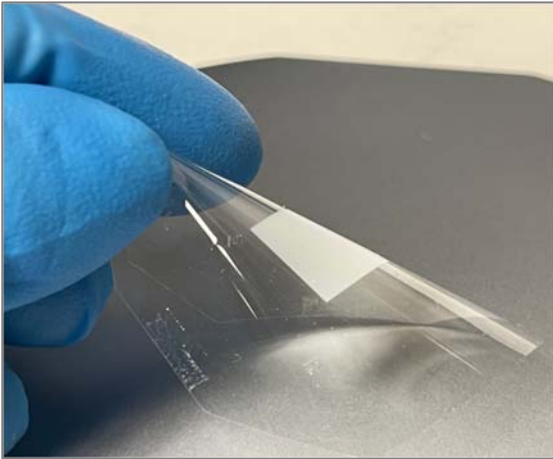
FOV = 70 degree

**4. STOB Series Metalens-Enabled Microlens Arrays for Imaging Applications**

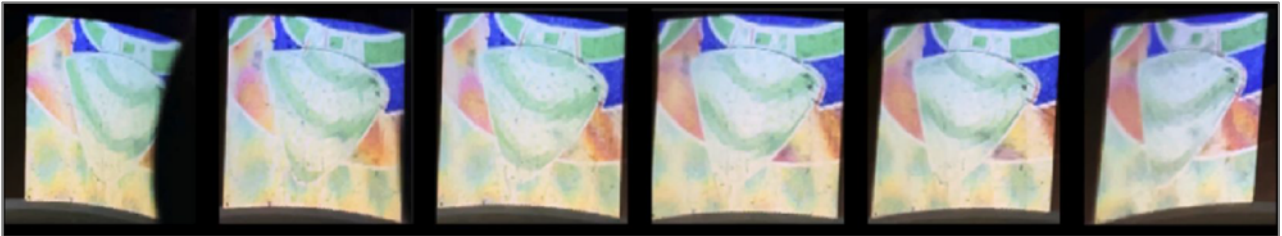
We have designed and built a freeform diffractive microlens array suitable for multiple applications in 3D integral imaging including:

- Anti-counterfeiting technology
- Physical security
- 3D displays
- Lightfield cameras
- Wavefront sensors

- Fiber coupling



Metalens-enabled microlens array on a flexible substrate for imaging applications.  
(Microlens pitch = 70 $\mu$ m, F-number: f/0.5, Substrate thickness 40 $\mu$ m)



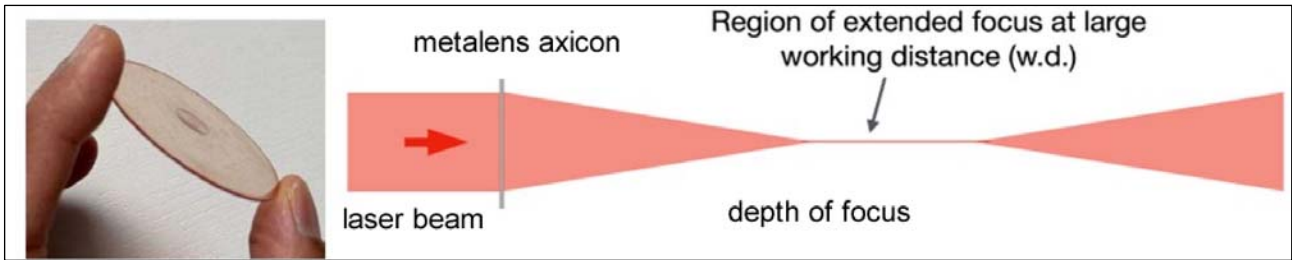
Integral imaging demonstrated using a metalens-enabled microlens array and a high-resolution color print. As the print plus the microlens array is tilted three dimensional patterns and colors change. This demonstration has applications in document security.

Major advantages of STOB Series Metalens technology:

- Low f# (0.5 and larger)
- Extended depth of focus for high robustness
- Broadband performance in the visible, NIR, or LWIR
- 100% fill factor
- Flexible device with ultra-low profile
- Low-cost, large volume manufacturing with nano imprint lithography
- Simplified alignment

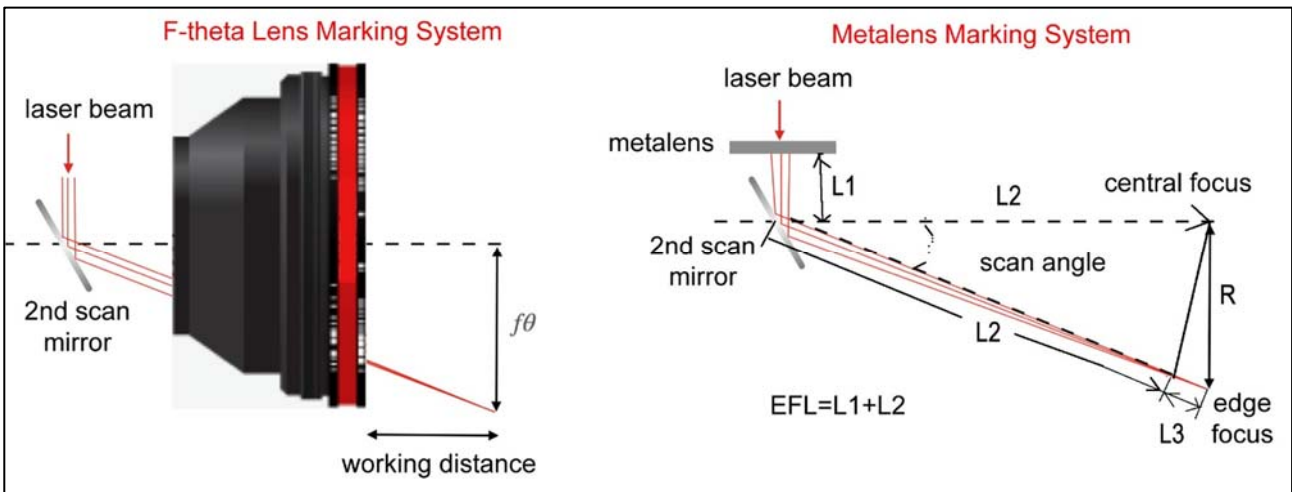
## How to Select a Metalens in Laser Marking System

Metalenses are very suitable for laser processing, as they provide a long depth of focus and can easily and accurately mark and process various non planar objects.



Compared with traditional f-theta marking systems, the metalens marking system has the following advantages:

- Ultra long depth of field (>75 mm), marking on non planar surfaces without the need for Z-axis movement, can also create consistent line width markings on non planar surfaces, especially suitable for 3D printing or non planar processing.
- Due to the elimination of f-theta lens, the size of the scanning and marking head has decreased significantly.
- Low cost, mass production.
- Customizable metalenses for any laser wavelength.
- Suitable for laser applications of all power levels, low-power laser applications can be used without coating.



Choosing a suitable metalens mainly considers laser wavelength, aperture (diameter of incident laser beam), effective focal length, depth of focus, diameter of focused spot, and laser power. At a laser power of around 50W, the metalens can operate stably without the need for coating. Choose the effective focal length based on the size of the marking area. The longer the focal length, the larger the marking area, but the larger the focusing spot. Therefore, it is necessary to choose a reasonable effective focal length.

Assuming that the distance from the metalens to the second scanning mirror is  $L_1$ , the distance from the second scanning mirror to the working surface is  $L_2$ , and the effective focal length of the metalens is  $EFL$ , then  $EFL=L_1+L_2$ . If the maximum scanning angle of the galvanometer is  $\theta$ , The distance between the center focus and the edge focus is the radius  $R$  of the marking area,  $R=TAN(\theta) * L_2$ ,  $R$ , the defocus amount at the outermost edge called as  $L_3$  is  $L_3=L_2/COSIN(\theta) - L_2$ , the defocus amount should be less than 1/2 of the depth of focus, and the marking will be as clear and uniform as the marking on the focal plane.

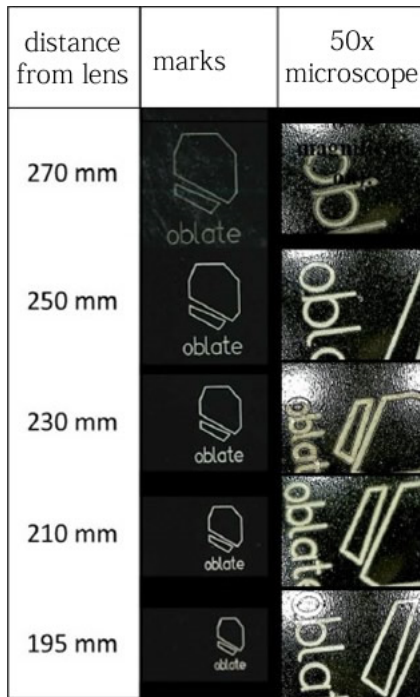
Assuming the side length of the square marking area and the maximum scanning optical angle of the galvanometer is  $\pm 20$  degrees, assuming  $L_1=50\text{mm}$ , calculate the center wavelength and defocus amount of the metalens  $\pm L_3$  as shown in the table below. When selecting the effective focal length  $EFL$



of the metalens, the distance from L1, which is the distance from the metalens to the second scanning mirror, also needs to be considered. That is, some focal lengths of the metalens  $EFL=L1+L2$ .

Marking area side length mm	Marking area radius R mm	Maximum scanning angle $\theta$	L2 mm	Effective focal length EFL mm	Defocus L3 mm
50	35.36	0.35	97.14	147.14	6.23
75	53.03	0.35	145.71	195.71	9.35
100	70.71	0.35	194.28	244.28	12.47
125	88.39	0.35	242.84	292.84	15.59
150	106.07	0.35	291.41	341.41	18.70
200	141.42	0.35	388.55	438.55	24.94
250	176.78	0.35	485.69	535.69	31.17
300	212.13	0.35	582.83	632.83	37.40
350	247.49	0.35	679.97	729.97	43.64
400	282.84	0.35	777.10	827.10	49.87

The following figure shows the marking effect at different distances between the marking surface and the metalens, with a defocus of up to 75mm, which can still be clearly marked.



The following table shows the range of some of our product parameters:

wavelength	Effective focal length EFL	Depth of focus (DOF)	diameter	Spot size
355 nm	25-100 mm	25, 50 mm	3-6 mm	25-250 $\mu$ m
532 nm	25-100 mm	25, 50 mm	3-6 mm	25-250 $\mu$ m
1064 nm	25-100 mm	25, 50 mm	3-6 mm	25-250 $\mu$ m
10.6 $\mu$ m	25-100 mm	25, 50 mm	3-6 mm	50-250 $\mu$ m